

JUL 18 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	)
	) ATTORNEY FILE NO.:
Inventors: Li et al.	) SLA0845
	)
Serial No.: 10/761,704	) Examiner: Erdem, Fazli
	)
Filed: January 21, 2004	) Customer No.: 55,286
	)
Title: ULTRA-SHALLOW METAL	) Group Art: 2826
OXIDE SURFACE CHANNEL	)
MOS TRANSISTOR	) Confirmation No.: 3680
	)

MAIL STOP AMENDMENTS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATION UNDER 37 CFR § 1.8

I hereby certify that this correspondence is being facsimile transmitted to the US Patent and Trademark Office, fax No. 571 273 8800, on this date 7/18/2006.

Date 7/18/2006 Signature 

MAIL STOP AMENDMENTS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT


The present communication is responsive to a restriction requirement mailed July 13, 2005, for the above-mentioned application.

The Applicant elects to pursue the Group II Claims, claims 4-8, 11-12, and 24, drawn to a method for making a semiconductor device.

The Applicant cancels claims 16-20 and 23 without traverse.

Respectfully submitted,

Date: 7/18/2006

  
Gerald Maliszewski  
Registration No. 38,054

Customer Number 55,286  
P.O. Box 270829  
San Diego, CA 92198-2829  
Telephone: (858) 451-9950  
Facsimile: (858) 451-9869  
gerry@ipatentit.net